

Expedited procedure
Under 37 CFR 1.116



1204.41259X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: T. UCHIDA, et al.
Serial No. 10/069,404
Filed: MAY 6, 2002
For: POLISHING MEDIUM FOR CHEMICAL-MECHANICAL
POLISHING, AND POLISHING METHOD
Group AU: 1765
Examiner: Lynette T. Umez Eronini
Confirm. No: 3597

Enter Amendment

AMENDMENT AFTER FINAL REJECTION

Mail Stop: AF - FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

L. T. U-E
3/16/2007

February 26, 2007

Sir:

In response to the Office Action mailed August 25, 2006, the period of response having been extended for three (3) months by the attached Petition for Extension of Time, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.